



I hereby certify that this Correspondence, together with the attached Form PTO-1449 and the cited non-US patent references, are being deposited with the United States Postal Service as first class mail postage prepaid in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date noted with my signature.

Daniel B. Ruble; Registration No. 40,794

DATE:

2/3/06

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Grah et al  
Serial No.: 10/725,209  
Filed: December 1, 2003  
Title: Method of Increasing the Gas Transmission Rate of a Film

Examiner: S. McClendon  
Docket: D-43583-01  
Art Unit: 1711

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

### FIFTH SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Applicants inform the Office of the information listed on the attached form PTO-1449. A copy of each listed reference that is not a U.S. patent or U.S. patent application publication is enclosed.

Applicants wish to make the Examiner aware of the following copending patent applications, which are owned by the assignee of the present application and which may relate to similar subject matter:

U.S. Patent Application Serial No. 11/142,044 filed June 1, 2005 to Grah et al entitled "Method of activating the shrink characteristic of a film" (Attorney Docket No. D43825-01 US);

U.S. Patent Application Serial No. 11/262,261 filed October 28, 2005 to Bekele entitled "Ultraviolet Light Absorbing Composition" (Attorney Docket No. D43872-01 US);

U.S. Patent Application Serial No. 11/208,464 filed August 18, 2005 to Grah entitled "Increasing the gas transmission rate of a film comprising fullerenes" (Attorney Docket No. D43948-01 US);

This Statement is timely under 37 C.F.R. § 1.97(c). Please charge the \$180 believed to be due under 37 C.F.R. §§ 1.17(p) and 1.97(c)(2) to deposit account number 07-1765.

Respectfully submitted,



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OMB No. 0651-0011

**INFORMATION DISCLOSURE  
CITATION**

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<b>Fifth Supplemental IDS</b>		

**U.S. PATENT DOCUMENTS**

Examiner Initials		Document Number	Date	Name	Class	Sub Class	Filing Date If Appropriate
		US 6,355,287	03-2002	Noel et al.			
		US 5,691,101	11-1997	Ushirogouchi et al			

**FOREIGN PATENT DOCUMENTS**

		Document Number	Date	Country	Class	Sub-Class	Translation	
							Yes	No

**OTHER DOCUMENTS (Including Authors, Title, Date, Pertinent Papers, etc.)**


EXAMINER

Date Considered

\*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.